

## **PDK release summary**

**PDK ID:** plessey-hjw  
**PDK version:** 0.1.0.R  
**PDK release date:** 01/04/2012  
**Fab/Foundry name:** PLESSEY  
**Technology name:** HJW - double polysilicon complementary bipolar process

This PDK supports BE (DRC/LVS) only.

### **Certified SILVACO EDA tool versions for this PDK version:**

Expert: 4.8.25.R  
Hipex: 3.4.22.R  
Guardian: 4.8.26.R